

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
BEFORE THE PATENT TRIAL AND APPEAL BOARD

In re patent of: Chistyakov	§	Petition for <i>Inter Partes</i> Review
	§	
U.S. Patent No. 7,811,421	§	Attorney Docket No.: 34789.98
	§	
Issued: October 12, 2010	§	Customer No.: 27683
	§	
Title: High Deposition Rate Sputtering	§	Real Party in Interest: Fujitsu
	§	Semiconductor Limited and Fujitsu
	§	Semiconductor America, Inc.

PETITIONER POWER OF ATTORNEY PURSUANT TO 37 CFR 42.10(b)  
FOR PETITION FOR *INTER PARTES* REVIEW

Petitioners **Fujitsu Semiconductor Limited and Fujitsu Semiconductor America, Inc.** hereby appoints the Practitioner(s) associated with **Customer Number 27683**, as its attorney(s) to prosecute and to transact all business in the Patent Trial & Appeal Board of the United States Patent and Trademark Office connected with *Inter Partes* Review of the above-identified patent.

Please direct all communication regarding this Petition to **Customer Number 27683**:

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The undersigned is authorized to sign this Power of Attorney on behalf of the Petitioner.

**Fujitsu Semiconductor Limited**

By: Takashi Kikuma  
Takashi Kikuma  
Director, IP Licensing Department  
Intellectual Property Unit

**Fujitsu Semiconductor America, Inc.**

By: Jesus E. Martinez  
Jesus Martinez  
General Counsel & Corporate Secretary